



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kusumoto, et al. Art Unit: 2814

Serial No.: 09/941,367 Examiner: Theresa T. Doan

Filed : August 28, 2001

Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM

SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

This statement is being filed with a Request For Continued Examination. No fee is believed to be due. However, please apply any deficiencies or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2 11 2004

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Substitute Form PTO-1449

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Patent and Trademark Office

O7977-010005

Application No. 09/941,367

Applicant

Kusumoto, et al.

Filing Date

(37 CFR \$48(b))

Group Art Unit

August 28, 2001

Attorney's Docket No. 09/941,367

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U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	4,498,951	02/12/1985	Tamura et al.			_
	AB	5,569,610	10/29/1996	Zhang et al.			
	AC	6,413,805	07/02/2002	Zhang et al.		*	
	AD	6,458,200	10/01/2002	Zhang			
	AE						
	AF						
	AG						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or				lation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AH	JP-04-037144	02/07/1992	Japan			Abs	
	AI	JP-06-267989	09/22/1994	Japan			Abs	
	AJ	JP-06-318701	11/15/1994	Japan			Abs	

Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner	Desig.			
Initial	ID	Document		
	AK			
	AL			
	AM			
	AN			

Examiner Signature	Date Considered			
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with				

next communication to applicant.